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August 13, 2007

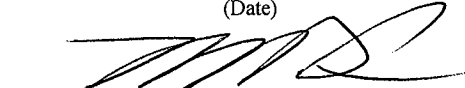
Commissioner for Patents
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I hereby certify that this correspondence, and any other attachment noted on the automated Acknowledgement Receipt, is being transmitted from within the Pacific Time zone to the Commissioner for Patents via the EFS Web server on:

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(Date)



Mincheol Kim, Reg. No. 51,306

Re: Title: DEVICE AND METHOD OF CORRECTING EXPOSURE DEFECTS IN
PHOTOLITHOGRAPHY
Letters Patent No. 6,812,999
Issued: November 2, 2006
Our Reference: MICRON.100C1

Dear Sir:

Enclosed for filing is a Certificate of Correction in connection with the above-identified patent.

As the errors cited in the Certificate of Correction were incurred through the fault of the Patent Office, no fee is believed to be required. However, please charge our Deposit Account No. 11-1410 for any fees that may be incurred with this request.

Respectfully submitted,

Knobbe, Martens, Olson & Bear, LLP



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Enclosures
4131007:jmo
081007

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